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Applicant : Osterheld et al.

Art Unit

: Unknown

Serial No. : 10/040.108

Examiner : Unknown

Filed Title : October 29, 2001 : POLISHING PAD HAVING A GROOVED PATTERN FOR USE IN CHEMICAL

MECHANICAL POLISHING

Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449, copies of which are enclosed

Under 35 USC §120, this application relies on the earlier filing date of application serial number 09/441,633, filed on November 16, 1999. The following references were submitted to and/or cited by the Office in the prior application and, therefore, are not provided in this application:

Desig. IDs:

AA-AR

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050. Respectfully submitted,

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I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

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